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				Application Number	09/704,936		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Filing Date	November 2, 2000		
				First Named Inventor	Lee A. NEITZEL		
				Art Unit	2476		
(Use as many sheets as necessary)				Examiner Name	A.C.Chemy-Lee A	Andrew	C.
Sheet	1	of	1	Attorney Docket Number	06005/35528		

	U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		

FOREIGN PATENT DOCUMENTS							
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/ACL/		Notice of Reason for Rejection, dated November 4, 2009.	
8		Japanese Patent Abstract Publication No. 05-053939, dated March 5, 1993.	
8000		Japanese Patent Abstract Publication No. 09-023285 dated January 21, 1997.	
\		Japanese Patent Abstract Publication No. 11-242640, dated September 7, 1999.	
W		Japanese Patent Abstract Publication No. 2000-020428 dated January 21, 2000.	
/ACL/		International Patent Application Publication No. WO 00/46669 dated August 10, 2000.	
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Examiner		Date	200144622
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